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(12) **United States Design Patent** (10) **Patent No.:** **US D918,848 S**  
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(54) **RETAINER OF CEILING HEATER FOR SEMICONDUCTOR FABRICATION APPARATUS**

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(30) **Foreign Application Priority Data**

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(52) **U.S. Cl.**  
USPC ..... **D13/182; D15/144.1**

(58) **Field of Classification Search**  
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CPC ..... H01L 21/67098; H01L 21/67103; H01L 21/67109; H01L 21/67115; H01L 21/67; H01L 21/673; H01L 21/6735; H01L 21/67369; H01L 21/67011; H01L 21/67757; B24B 5/00; B24B 37/27; B24B 37/30; B24B 37/32; B24B 29/00; B24B 7/22; B24B 7/228; C23C 16/4587; C23C 16/45546; C23C 16/4584; C23C 16/46; C23C 16/458

See application file for complete search history.

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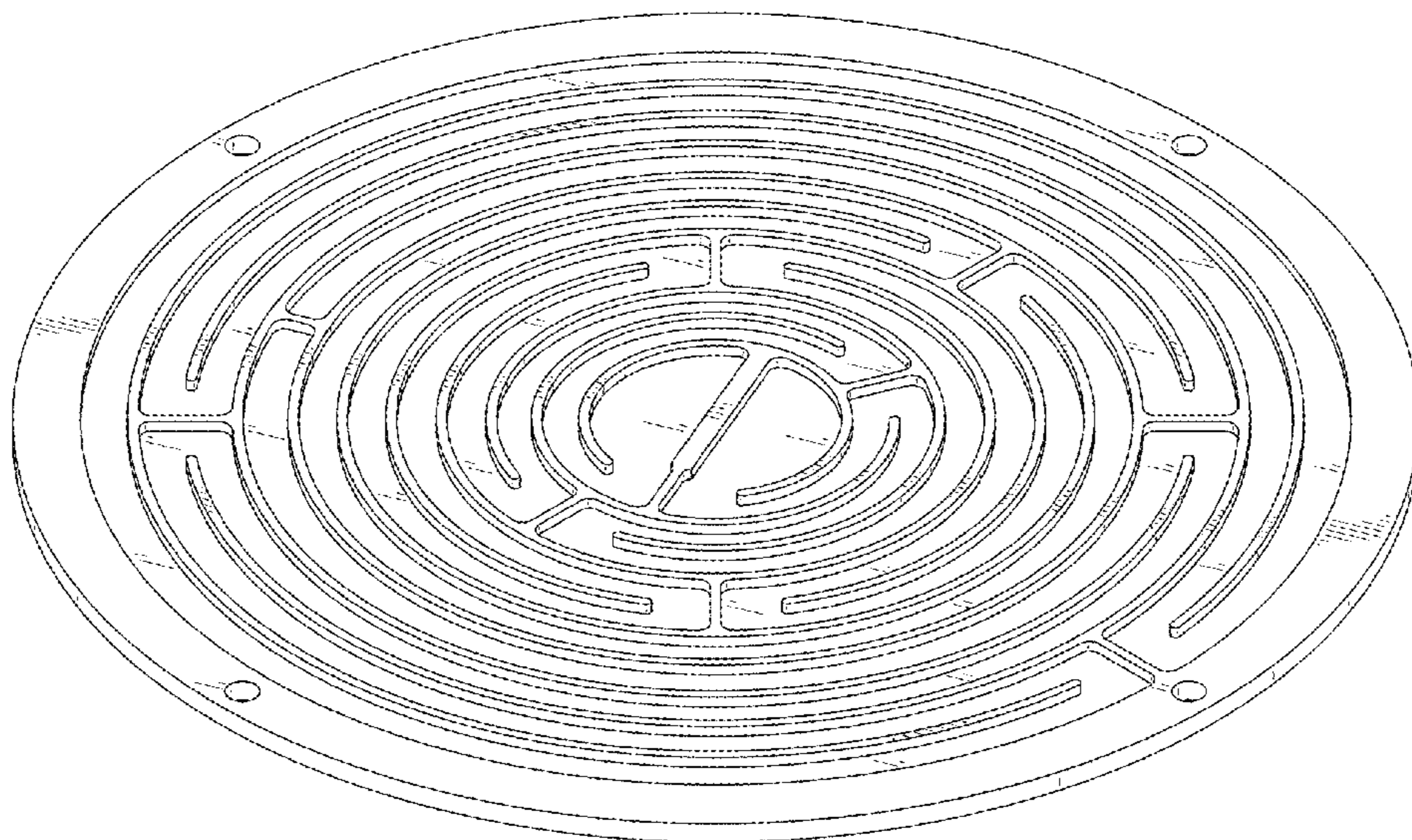
(57) **CLAIM**

The ornamental design for a retainer of ceiling heater for semiconductor fabrication apparatus, as shown and described.

**DESCRIPTION**

FIG. 1 is a front, top and right side perspective view of a retainer of ceiling heater for semiconductor fabrication apparatus showing our new design;  
FIG. 2 is a front elevational view thereof;  
FIG. 3 is a left side elevational view thereof;  
FIG. 4 is a right side elevational view thereof;  
FIG. 5 is a top plan view thereof; and  
FIG. 6 is a bottom plan view thereof; and,  
FIG. 7 is a rear elevational view.

**1 Claim, 4 Drawing Sheets**



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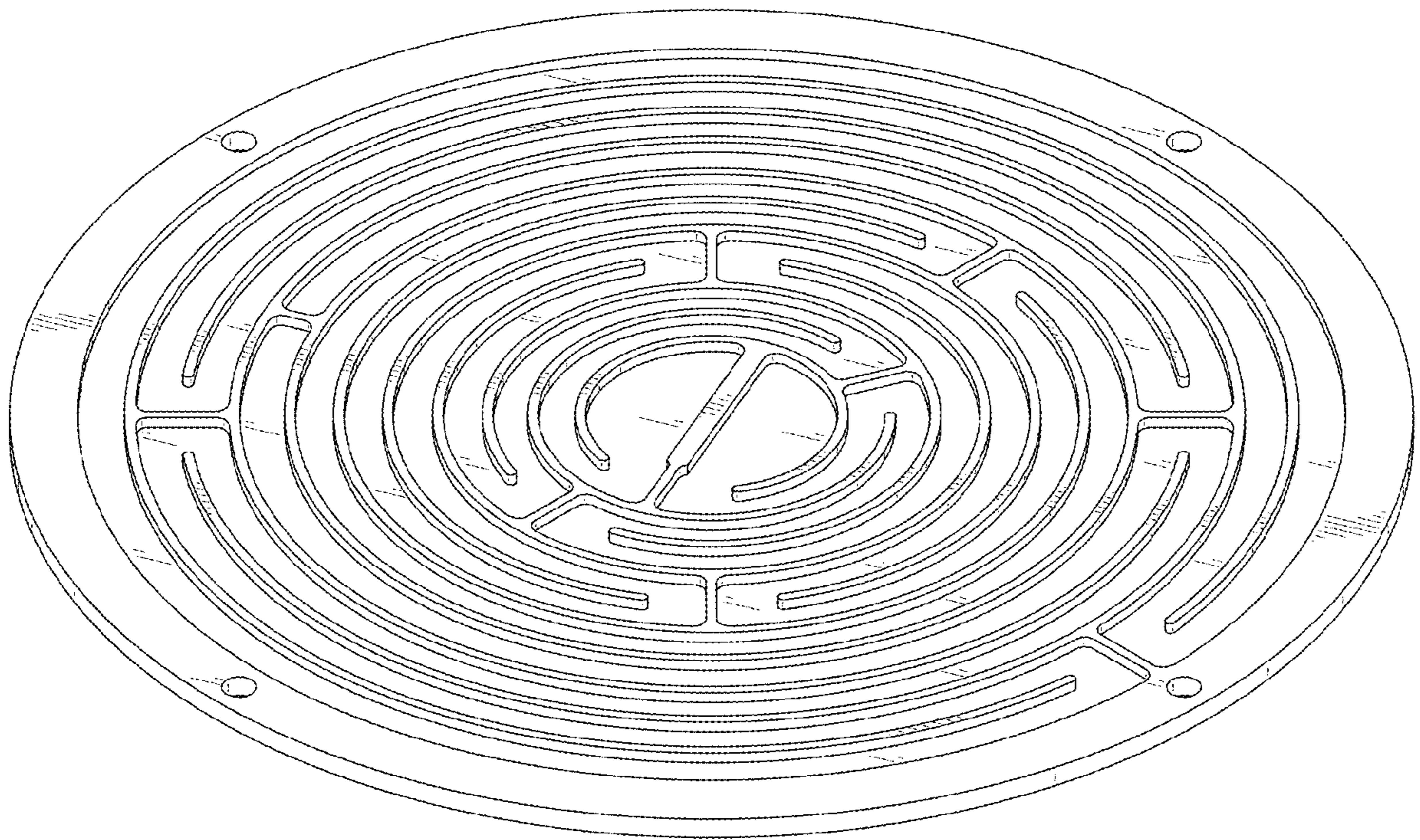
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*FIG. 1*

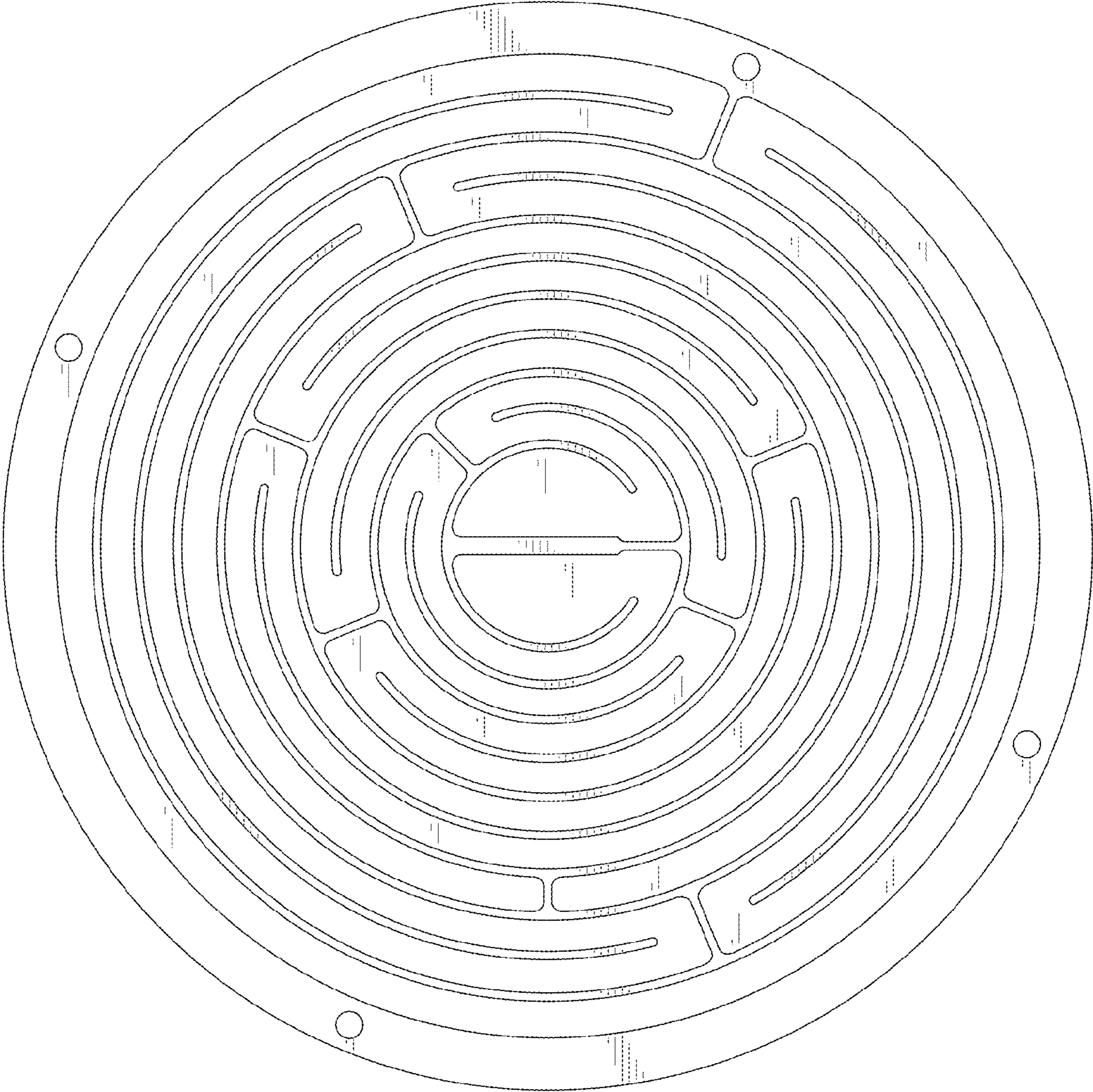
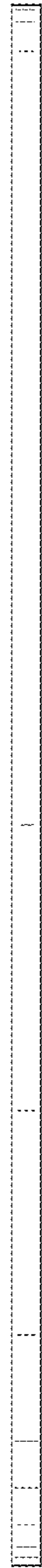


FIG. 2



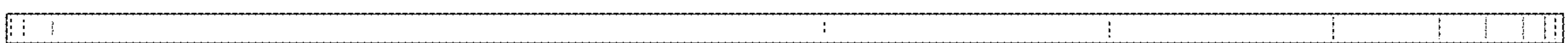
*FIG. 3*



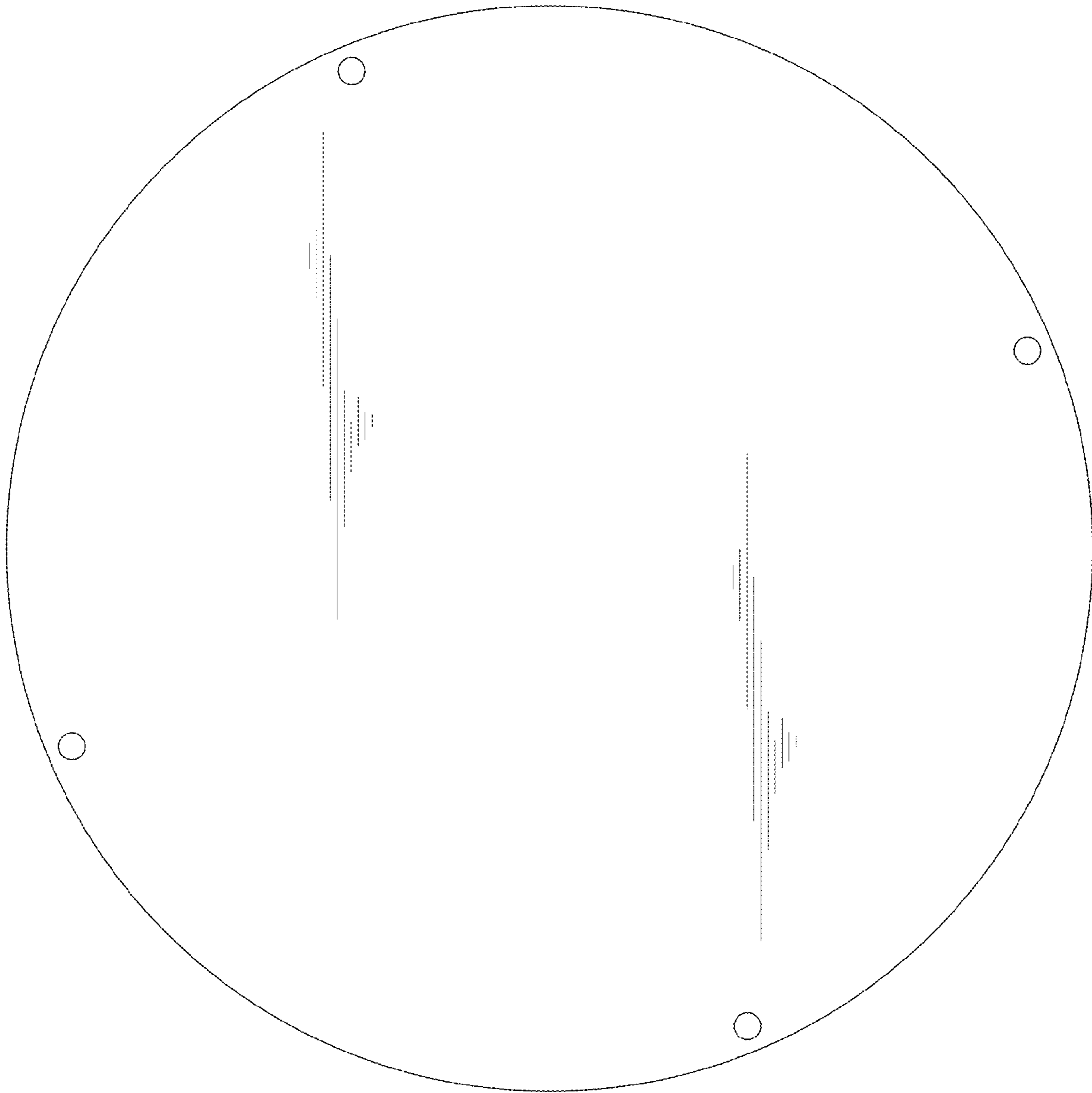
*FIG. 4*



*FIG. 5*



*FIG. 6*



**FIG. 7**